



PATENT APPLICATION NO.: 10/519,142
ATTORNEY DOCKET: 55320.000401

IFW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Number : 10/519,142 Confirmation No.: 3201
Applicant : Henrik JENSEN, et al.
Filed : December 27, 2004
Title : METHOD FOR PRODUCTION OF A PRODUCT HAVING
SUBMICRON PRIMARY PARTICLE SIZE, PRODUCT
PRODUCED BY THE METHOD AND APPARATUS FOR USE
OF THE METHOD
TC/Art Unit : 1754
Examiner: : Unassigned

Docket No. : 55320.000401
Customer No. : 21967

MAIL STOP AMENDMENT
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Sir:

In accordance with 37 C.F.R. §§ 1.97 and 1.98, and in compliance with the duty of disclosure set forth in 37 C.F.R. § 1.56, applicants submit attached Form PTO-SB/08A (modified) for consideration and request the references cited therein be made of record by the U.S. Patent and Trademark Office in the above-captioned application.

Applicants also wish to bring to the Examiner's attention the following co-pending U.S. patent application: U.S. Application Serial Number 10/584,301 (filed June 23, 2006). An indication of consideration of the co-pending application by the Examiner would be appreciated.

Applicants respectfully point out that the submission of the listed references in this Information Disclosure Statement is not an admission that they are prior art or that they are material to patentability of any claims of the application. Also, the submission of this Information Disclosure Statement is not an indication that a search has been made by Applicants.

For the convenience of the Examiner in considering the cited references, a copy of each of the cited references is enclosed with this communication. In considering the cited references, it may be noted by the Examiner that certain of the references may contain markings, underlinings, and/or other notations. These markings, underlinings, and/or other notations are not to be construed as drawing the Examiner's attention either to selected parts or away from other parts of the cited references. Any such markings were either present on the copies of the cited references obtained by the associated individuals, or were made thereon during the study of the references by the associated individuals.

Consideration of the foregoing plus the prompt return of a copy of the enclosed Form SB/08A with the Examiner's initials in the left column in accordance with MPEP 609 are respectfully requested.


In accordance with 37 C.F.R. § 1.97(b), this Information Disclosure Statement is believed to be submitted prior to issuance of a first Office Action. Therefore, it is respectfully submitted that no fee is required for consideration of this information. However, in the event any fee is deemed necessary, the Commissioner is authorized to charge the undersigned's Deposit Account No. 50-0206.

Respectfully submitted,

HUNTON & WILLIAMS LLP

Dated: 10/20/06

By:



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Substitute for form 1449/PTO

INFORMATION DISCLOSURE STATEMENT BY APPLICANT

(use as many sheets as necessary)

Application Number	10/519,142
Filing Date	December 27, 2004
First Named Inventor	Henrik JENSEN, et al.
Art Unit	1754
Examiner Name	Unassigned
Attorney Docket Number	55320.000401

Sheet **1 of 1**

OTHER DOCUMENTS - NON-PATENT LITERATURE DOCUMENTS

*Examiner Initials	Cite No.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published	TRANSLATION	
			YES	NO
	1.	Jensen, et al., "Low Temperature Synthesis of Metal Oxides by a Supercritical Seed Enhanced Crystallization (SSEC) Process", Ind. Eng. Chem. Res., Vol. 45, pg. 3348-3353, 2006.	<input type="checkbox"/>	<input type="checkbox"/>
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			<input type="checkbox"/>	<input type="checkbox"/>

EXAMINER SIGNATURE

DATE CONSIDERED

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.